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Front Matter: Volume 9375

, "Front Matter: Volume 9375," Proc. SPIE 9375, MOEMS and Miniaturized Systems XIV, 937501 (26 March 2015); doi: 10.1117/12.2190576

SPIE.

Event: SPIE OPTO, 2015, San Francisco, California, United States

PROCEEDINGS OF SPIE

MOEMS and Miniaturized Systems XIV

**Wibool Piyawattanametha
Yong-Hwa Park**
Editors

**9–12 February 2015
San Francisco, California, United States**

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Published by
SPIE

Volume 9375

Proceedings of SPIE 0277-786X, V. 9375

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

MOEMS and Miniaturized Systems XIV, edited by Wibool Piyawattanametha,
Yong-Hwa Park, Proc. of SPIE Vol. 9375, 937501 · © 2015 SPIE
CCC code: 0277-786X/15/\$18 · doi: 10.1117/12.2190576

Proc. of SPIE Vol. 9375 937501-1

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Author(s), "Title of Paper," in *MOEMS and Miniaturized Systems XIV*, edited by Wibool Piyawattanametha, Yong-Hwa Park, Proceedings of SPIE Vol. 9375 (SPIE, Bellingham, WA, 2015) Article CID Number.

ISSN: 0277-786X

ISBN: 9781628414653

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA

Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445

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